

520.37607VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : S. TAKATANI et al
Serial No. : (New divisional application under
37 CFR §1.53[b] of application
Serial No. 09/381,396)
Filed : February 13, 2002
Title : SEMICONDUCTOR DEVICE AND FABRICATION
METHOD THEREOF
Group Art Unit : 2811
Examiner : D. KANG

LETTER CLAIMING RIGHT TO FOREIGN PRIORITY

Assistant Commissioner for Patents February 13, 2002
Washington, DC 20231

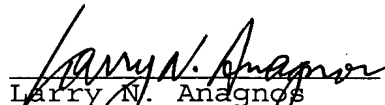
Sir:

Under the provisions of 35 USC §119 and 37 CFR §1.55,
Applicants hereby claim the right of foreign priority based
on:

JAPANESE PATENT APPLICATION NOS.:
9-074993 - Filed March 27, 1997
9-074994 - Filed March 27, 1997

Certified copies of the priority documents were filed
in PCT/JP98/01271 on May 1, 1998.

Respectfully submitted,
ANTONELLI, TERRY, STOUT & KRAUS, LLP


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